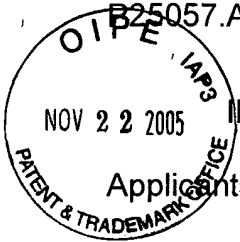


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Katsuyuki NAKADA et al.

Group Art Unit : 1752

Appl. No. : 10/801,689

Examiner : Not Yet Assigned

Filed : March 17, 2004

Confirmation No. : 1890

For : RESIST PATTERN FORMING METHOD AND RESIST PATTERN FORMING SYSTEM

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop AMENDMENT
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and supplemental to the Information Disclosure Statement filed on June 16, 2004, Applicants hereby submit a copy of a Chinese Office Action dated August 19, 2005, together with an English language translation of the same, with respect to patent family member Chinese Patent Application No.

200410030444.6, in which the following document was cited:

U.S. Patent Application Publication No. 2002/0123010.

The relevance to the document, as ascertained by the Chinese Examiner applying Chinese rules to the claims, is set forth in the Search Report.

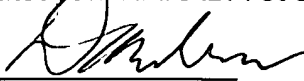
Further to 37 C.F.R. §1.98 (a)(2)(ii), a copy of the U.S. patent is not enclosed herewith. However, if any copies are needed, the Examiner is respectfully requested to contact the undersigned.

Applicants respectfully request that the Examiner consider the above material and cite the same. The above-noted document is listed on the attached PTO-1449 Form. The Examiner is requested to initial the appropriate spaces on the attached Form and to return a copy of the completed Form to Applicants with the next official communication in the present application.

Applicants note that an Office Action on the merits has not issued in the present application, and thus no fee is believed necessary to ensure consideration of the submitted material. However, if an Office Action on the merits has issued and is crossing this statement in the mail, the undersigned authorizes the Commissioner to charge any fee necessary for the consideration of this statement, including any payment under 37 C.F.R. §1.17 (p) to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Katsuyuki NAKADA et al.



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November 18, 2005
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FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT
BY APPLICANT
 (Use several sheets if necessary)

U.S. Department of Commerce
 Patent and Trademark Office

Atty. Docket No.
 P25057

Application No.
 10/801,689

Applicant
 Katsuyuki NAKADA et al.

Filing Date
 March 17, 2004

Group
 1752

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	2002 /	0 1 2 3 0 1 0	09/05/02	ANGELOPOULOS et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.